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DEC 27 2004
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PATENT & TRADEMARK OFFICE

IFW

Docket No. EATNP150US **03-IMP-006**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant:	Peter L. Kellerman et al.
Application No.:	10/683,679
For:	MEMS BASED CONTACT CONDUCTIVITY ELECTROSTATIC CHUCK
Filing Date:	October 10, 2003
Examiner:	David Nhu
Art Unit:	2818

REPLY TO OFFICE ACTION DATED SEPTEMBER 24, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir or Madam:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following remarks.